

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: TOMINAGA KOJI ET AL. .)
Serial No.: 10/550,805) Group Art Unit: 2813
Filed: July 12, 2006)
For: METHOD FOR FORMING AN)
INSULATING FILM IN A) Examiner: Luke, Daniel M.
SEMICONDUCTOR DEVICE) Confirmation No. 3990
)
)

VIA EFS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR RECONSIDERATION

Sir:

This Request for Reconsideration is respectfully submitted in response to the Office Action dated October 17, 2008. Applicants hereby respectfully petition for a two-month extension of time. If there are any charges with respect to this Request for Reconsideration or otherwise, please charge them to Deposit Account No. 06-1130 maintained by Applicants' attorneys.